

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tetsuhiro Iwai, et al.
Appn. No. : 10/621,497
Filed : July 17, 2003
Title : PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD

Conf. No. : 2610
TC/A.U. : 1765
Examiner : Lan Vinh

Customer No. : 000,116
Docket No. : 35908

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Sir:

This communication is in response to the Notice of Non-Compliant Amendment dated September 13, 2005 (Paper No. 20050912). The one-month period for responding to the Notice expires on October 13, 2005.

Please amend the above-identified application in the following manner.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Suzanne B. Gagnon

Name of Attorney for Applicant(s)

Signature of Attorney

September 19, 2005

Date